

# arCuDia / SbS-Dia.

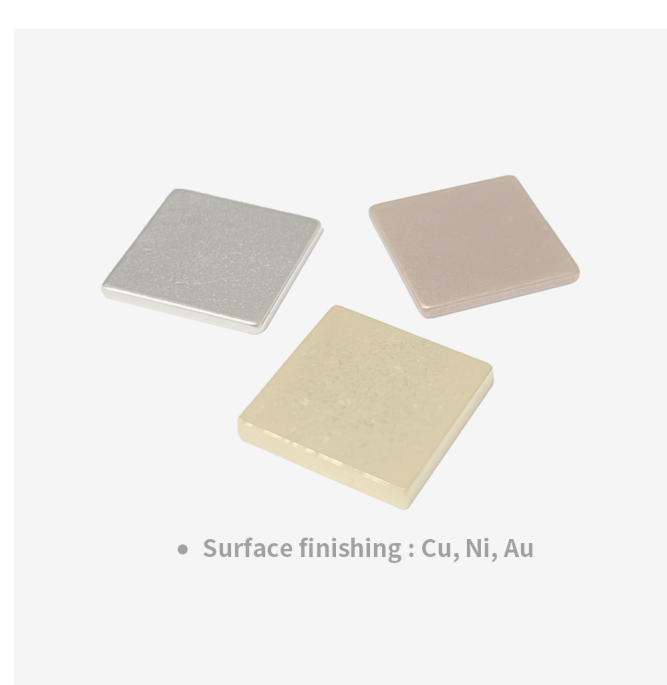
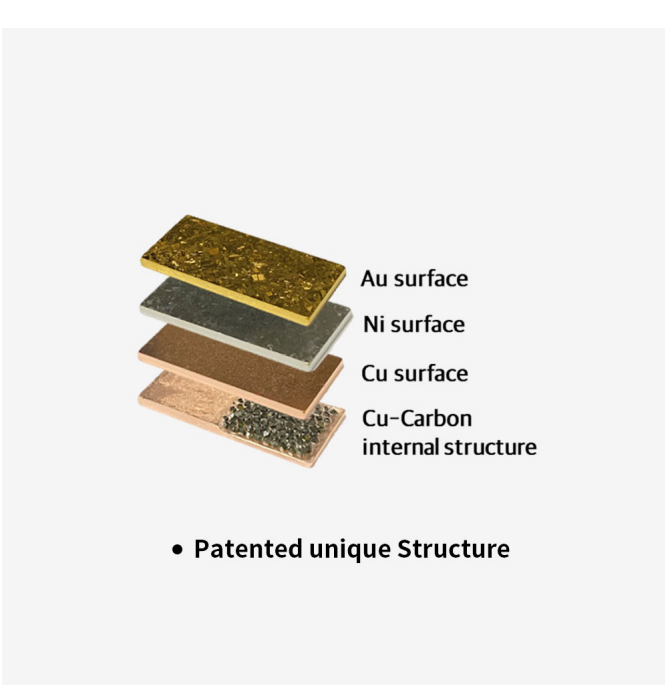
Heat spreader for extreme applications

## Dimension

- Width : ~ 108mm
- Length : ~ 108mm
- Thickness :  $\geq 0.7$  mm

## Features

- Patented unique Structure
- Hole, Ear, Rectangular type
- Surface finishing : Cu, Ni, Au
- Ag-Brazing (800°C) is available
- Copper-Carbon New Composite Materials
- Heat spreader with strain balanced structure
- high performance heat dissipation substrates with higher TC and lower CTE
- The world's highest performance heat dissipating substrate for semiconductor packages



[Product Inquiry](#)

[List](#)

## > Applications

- > 5G / 6G wireless communications
- > Aircraft & Aero space communications
- > Power modules for EV & Self-driving
- > CPUs, Servers, Internet switches, ASICs, Wearables
- > Lasers, Optical communications



## Typical product features

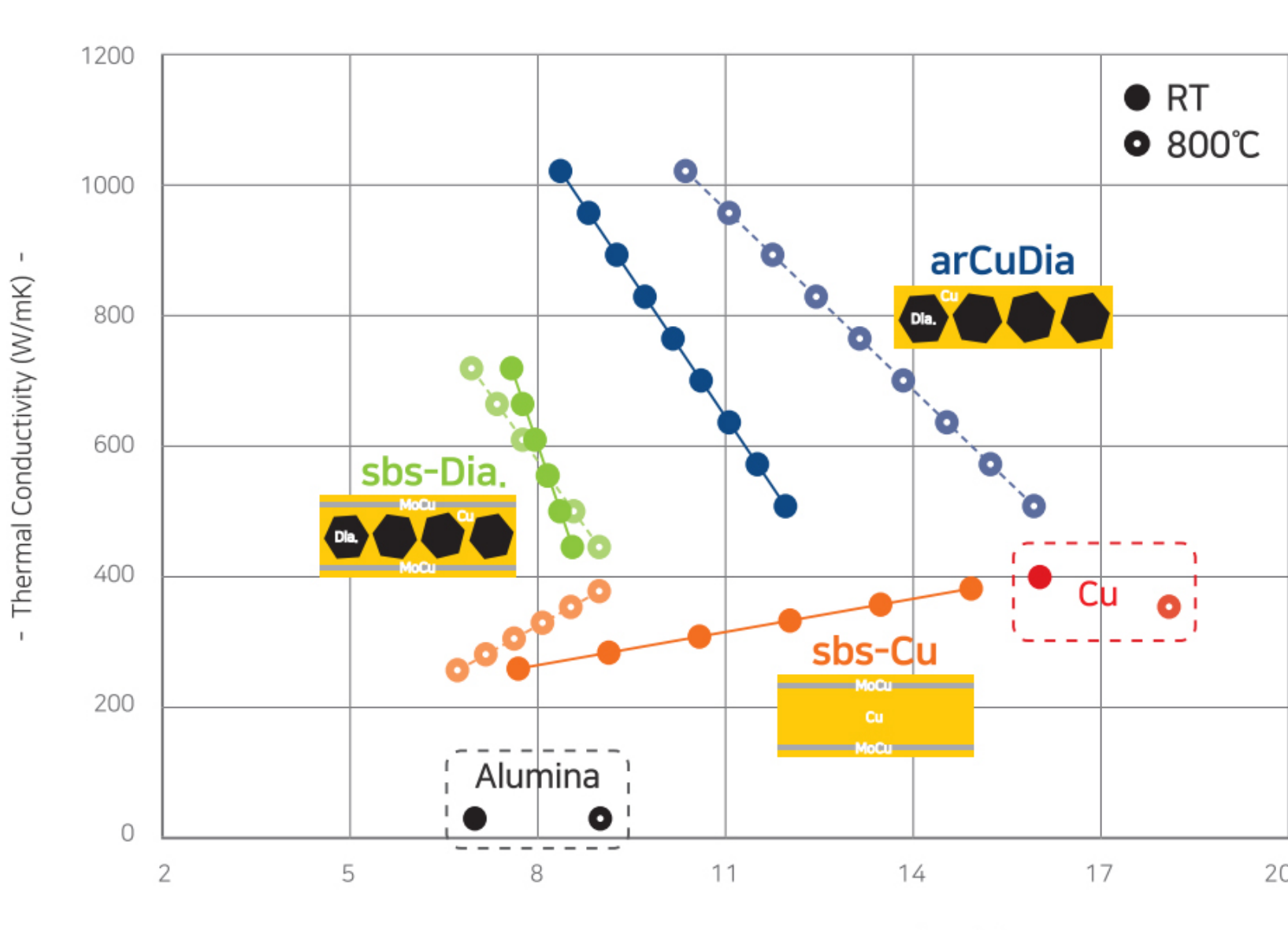
TC (Thermal conductivity)	600~1,000 W/mK	
CTE (Coefficient of Thermal Expansion)	7~9ppm/K @RT	
High reliability under thermal cycling test, -65~150°C		
Design	thickness	0.2 ~ 5.0mm
	size	~100mmx100mm
	shape	Hole, Ear, Step
	surface materials	Optionable with Cu, Ni, Au
Applicable to 800°C ceramic brazing with < 30um bowing		

## > Typical Properties

- > arCuDia = ar (aero space) Cu-Diamond structure
- > SbS = Strain balanced Structure

Model		*arCuDia		*SbS-Dia.	SbS-Cu
Structure		Copper-Diamond		Cu/CuMo/CuDia /CuMo/Cu	Cu/CuMo/Cu /CuMo/Cu
Dia. Volume ratio		45±5%	35%±5%	30%±5%	-
CTE (ppm/K)	RT	7.2	8.5	8.4	12.5
	RT~200°C	8.4	9.7	9.1	11.8
	RT~400°C	9.3	10.5	9.2	9.5
	RT~800°C	10.5	11.7	9.1	8.1
Thermal conductivity (W/m K)		1000	800	600	360
Thickness (mm)		2.0 ≤ t	0.35 ≤ t	0.7 ≤ t	0.25 ≤ t

## > TC vs. CTE



## Thermal cycling test based on MIL-STD-883K-C

GaN on SiC on Cu-Diamond : -65 ~ +150°C, 1,000 cycling

### > GaN / SiC Die bonded at 300°C with AuSn

- > Solid bonding interface
- > No cracks / No bowing / No voids
- > No delamination in bonding interface

